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## Interactive comment on "Constraining uncertainties in particle wall-deposition correction during SOA formation in chamber experiments" by

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Received and published: 6 January 2017 We greatly value the careful reading and the detailed comments provided by the referees. The responses to the comments of the two referees in our direct reply (shown in attached supplement) and within the revised manuscript (see marked copy) are

provided. The pages and lines indicated below correspond to those in the marked copy.

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Please also note the supplement to this comment: http://www.atmos-chem-phys-discuss.net/acp-2016-820/acp-2016-820-AC1- supplement.pdf

Interactive comment on Atmos. Chem. Phys. Discuss., doi:10.5194/acp-2016-820, 2016.